

PTO/SB/08A (08-03)

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet 1 of 4

Complete If Known

Application Number	10/047,454
Filing Date	January 14, 2002
First Named Inventor	Victor B. Kley
Art Unit	2878
Examiner Name	Thanh X Luu
Attorney Docket Number	020921-001110US

U.S. PATENT DOCUMENTS+

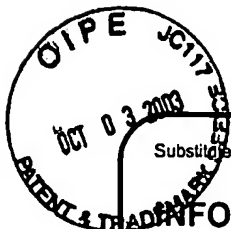
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		Number	Kind Code ² (if known)			
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Sheet 2 of 4

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Application Number	10/047,454
Filing Date	January 14, 2002
First Named Inventor	Victor B. Kley
Art Unit	2878
Examiner Name	Thanh X Luu
Attorney Docket Number	020921-001110US

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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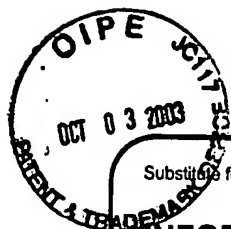
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Sheet 3 of 4

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		Number	Kind Code ² (if known)			
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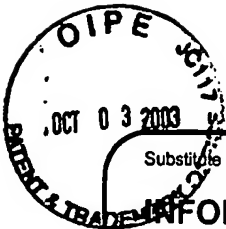
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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ³
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
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Sheet 4 of 4

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Application Number	10/047,454
Filing Date	January 14, 2002
First Named Inventor	Victor B. Kley
Art Unit	2878
Examiner Name	Thanh X. Luu
Attorney Docket Number	020921-001110US

NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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